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PATENT

## IN THE UNITED STATES DESIGNATED OFFICE (DO/US)

PCT/US2004/023869  
INTERNATIONAL APPLICATION NO.

26 July 2004 (26.07.2004)  
INTERNATIONAL FILING DATE

25 July 2003 (25.07.2003)  
PRIORITY DATE CLAIMED

## TITLE OF INVENTION

SEMICONDUCTOR ELEMENTS HAVING ZONES OF REDUCED OXYGEN

## APPLICANT(S) FOR DO/US

Ralf Jonczyk, Scott L. Kendall and James A. Rand

Mail Stop PCT  
Attention: DO/US  
Commissioner for Patents  
P.O. Box 1450  
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*Janet M. Stevens*  
Janet M. Stevens

## PRELIMINARY AMENDMENT

Sir:

Prior to examination, please amend the subject application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.